



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

January 10, 2025

IGI Report Number **LG675545873**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **10.79 X 7.49 X 5.09 MM**

GRADING RESULTS

Carat Weight **4.07 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

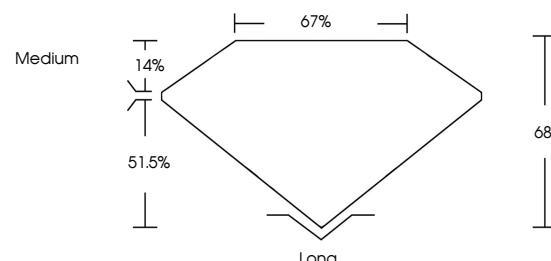
Fluorescence **NONE**

Inscription(s) **IGI LG675545873**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

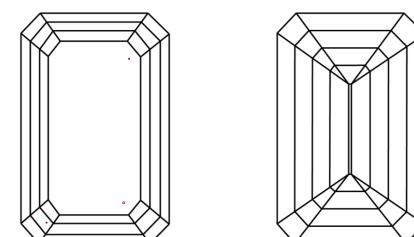
LG675545873
Report verification at igi.org

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
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Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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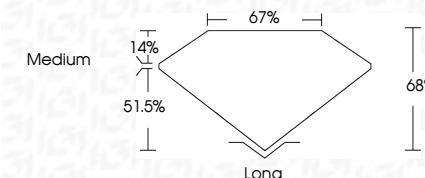
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IGI

January 10, 2025	IGI Report No LG675545873	EMERALD CUT	4.07 CARATS	E	VS 1	0.65%	0.75%	Medium	Long	EXCELLENT	EXCELLENT	NONE	IGI LG675545873
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